



Attorney Docket No. 0756-7176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji DAIRIKI

Serial No. 10/625,737

Filed: July 24, 2003

For: SEMICONDUCTOR DEVICE

MANUFACTURING METHOD, HEAT

TREATMENT APPRATUS AND

HEAT TREATMENT METHOD

) Group Art Unit: 2822

) Examiner: Maria F. Guerrero

) CERTIFICATE OF MAILING

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INFORMATION DISCLOSURE STATEMENT

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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

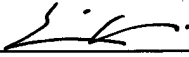
A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be

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A duplicate copy of this sheet is attached.

Respectfully submitted,



Eric J. Robinson
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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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Substitute for form 1449A/PTO <div style="text-align: center; font-weight: bold; font-size: 1.2em;"> INFORMATION DISCLOSURE STATEMENT BY APPLICANT </div> <div style="text-align: center; font-size: 0.8em;"> (use as many sheets as necessary) </div> <div style="display: flex; justify-content: space-between; margin-top: 10px;"> Sheet 1 of 1 </div>		<div style="text-align: center; font-weight: bold; font-size: 0.9em;">Complete if Known</div> <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 60%;">Application Number</td> <td>10/625,737</td> </tr> <tr> <td>Filing Date</td> <td>July 24, 2003</td> </tr> <tr> <td>First Named Inventor</td> <td>Koji DAIRIKI</td> </tr> <tr> <td>Group Art Unit</td> <td>2822</td> </tr> <tr> <td>Examiner Name</td> <td>Maria Guerrero</td> </tr> <tr> <td>Attorney Docket Number</td> <td>0756-7176</td> </tr> </table>		Application Number	10/625,737	Filing Date	July 24, 2003	First Named Inventor	Koji DAIRIKI	Group Art Unit	2822	Examiner Name	Maria Guerrero	Attorney Docket Number	0756-7176
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Attorney Docket Number	0756-7176														

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		2001/0005019		Ishikawa	06/28/2001	
		2001/0005606		Tanaka et al.	06/28/2001	
		2001/0009283		Arao et al.	07/26/2001	
		2001/0015441		Kawasaki et al.	08/23/2001	
		2002/0068422		Dairiki et al.	06/06/2002	
		5,529,937		Zhang et al.	06/25/1996	
		5,643,826		Ohtani et al.	07/01/1997	
		5,654,203		Ohtani et al.	08/05/1997	
		5,731,637		Hori et al.	03/24/1998	
		5,923,962		Ohtani et al.	07/13/1999	
		6,140,166		Ohtani et al.	10/31/2000	
		6,140,668		Mei et al.	10/31/2000	
		6,143,630		Tregilgas	11/07/2000	
		6,162,667		Funai et al.	12/19/2000	
		6,201,585		Takano et al.	03/13/2001	
		6,285,042		Ohtani et al.	09/04/2001	
		6,306,694		Yamazaki et al.	10/23/2001	
		6,759,313		Yamazaki et al.	07/06/2004	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Crowder, M., et al., <i>Low-Temperature Single-Crystal Si TFT's Fabricated on Si Films Processed Via Sequential Lateral Solidification</i> , IEEE Electron Device Letters, Vol. 19, No. 8, Pages 306-308, August 1, 1998.	
		Radnoczi, G., et al., <i>Al Induced Crystallization of a-Si</i> , Journal of Applied Physics, Vol. 69, No. 9, Pages 6394-6399, May 1, 1991.	

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